

Application Data Sheet

Application Information

Filing Date:: 10/2/2003 12:00:00AM
Application Type:: Regular
Subject Matter:: Utility
CD_ROM or CD-R?: None
Title:: EXPOSURE APPARATUS, MAINTENANCE
METHOD THEREFOR, SEMICONDUCTOR DEVICE
MANUFACTURING METHOD, AND
SEMICONDUCTOR MANUFACTURING FACTORY
Attorney Docket Number:: 00862.022227.1
Total Drawing Sheets:: 15
Small Entity?: No
Secrecy Order in Parent Appl.?: No

Applicant Information

Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Hiroshi
Family Name:: KUROSAWA
City of Residence:: Chiba
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 5514

Representative Information

Representative Customer Number::	05514
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Division of	09/858,964	05/17/2001

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	148831/2000 (Pat.)	05/19/2000	Yes

Assignee Information

Assignee name:: CANON KABUSHIKI KAISHA
Street of mailing address:: 3-30-2 Shimomaruko, Ohta-Ku
City of mailing Address:: Tokyo
Country of mailing address:: Japan